

[54] MICROMETER

[75] Inventor: David Brickwood, London, England

[73] Assignee: James Neill Holdings Limited, Sheffield, England

[**] Term: 14 Years

[21] Appl. No.: 829,988

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[51] Int. Cl. D10-04

[52] U.S. Cl. D10/73

[58] Field of Search D10/70-74, D10/73; 33/143 M, 143 J, 143 R, 143 K, 143 F

[56] References Cited

U.S. PATENT DOCUMENTS

1,703,736	2/1929	Jacob	33/143 M
3,176,401	4/1965	Costantino	33/143 M X
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Primary Examiner—Nelson C. Holtje
Attorney, Agent, or Firm—Robert A. Cesari

[57] CLAIM

The ornamental design for a micrometer, substantially as shown.

DESCRIPTION

FIG. 1 is a front elevational view of a micrometer showing my new design;

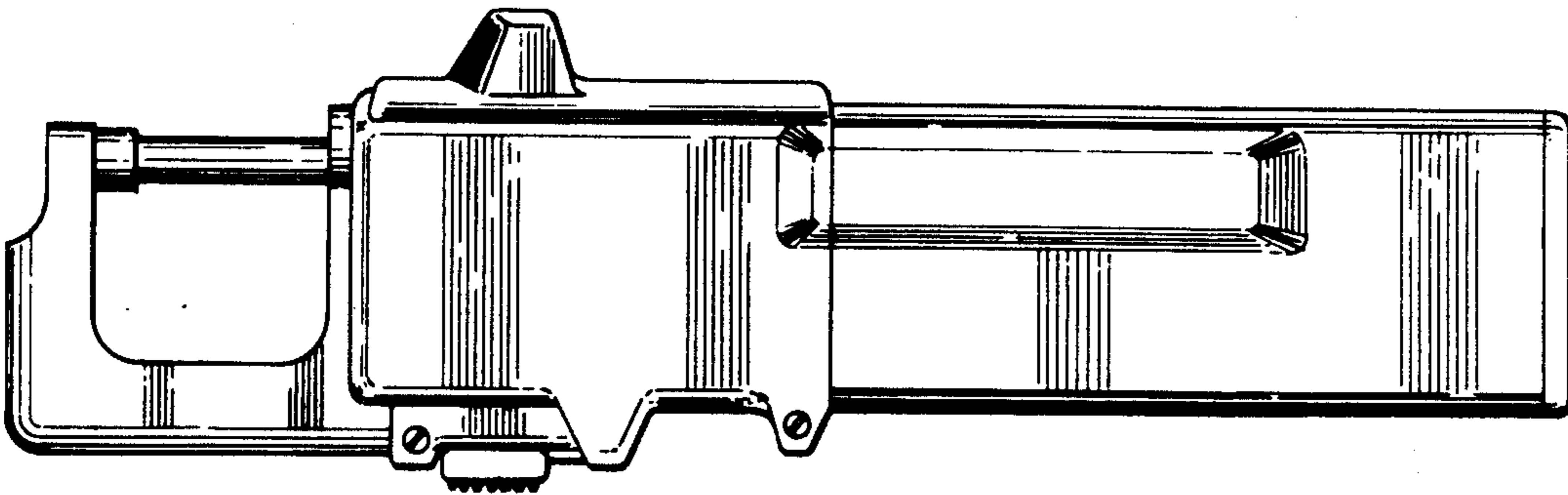
FIG. 2 is a rear elevational view thereof;

FIG. 3 is a right side elevational view thereof;

FIG. 4 is a left side elevational view thereof;

FIG. 5 is a bottom plan view thereof;

FIG. 6 is a top plan view thereof.



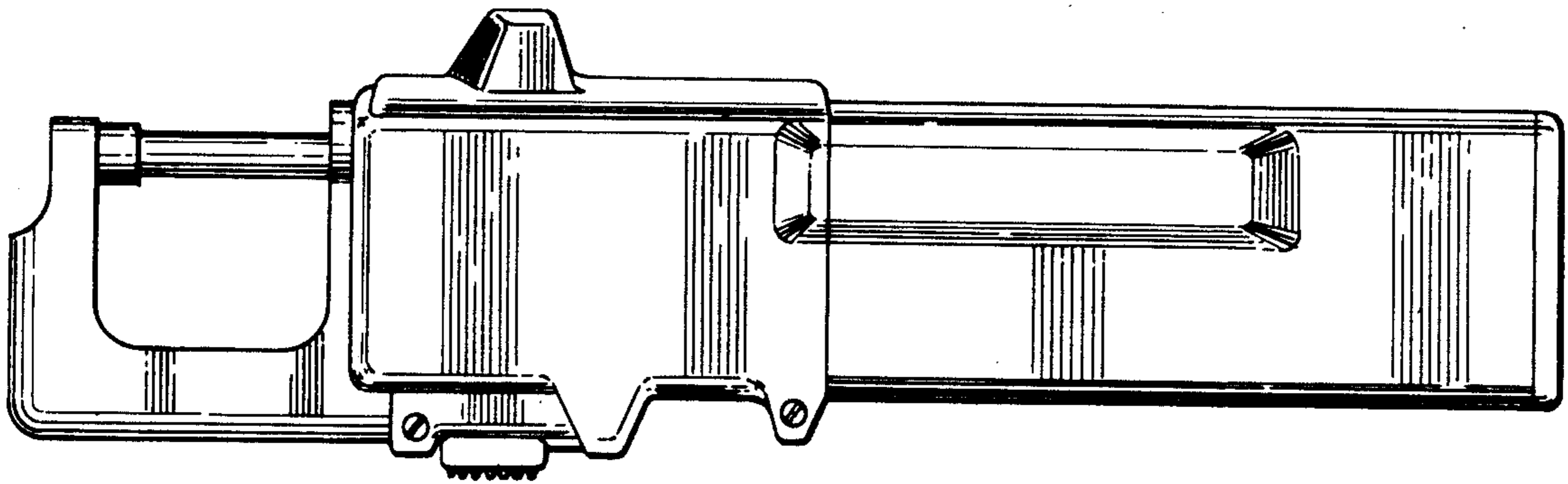


FIG. 1

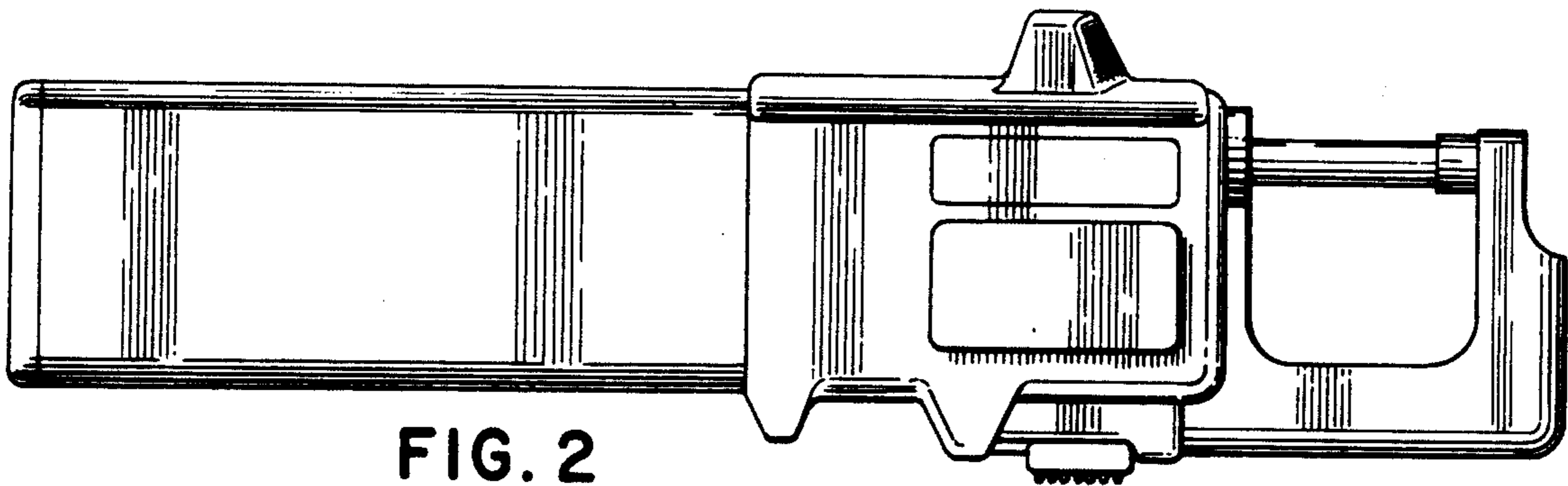


FIG. 2

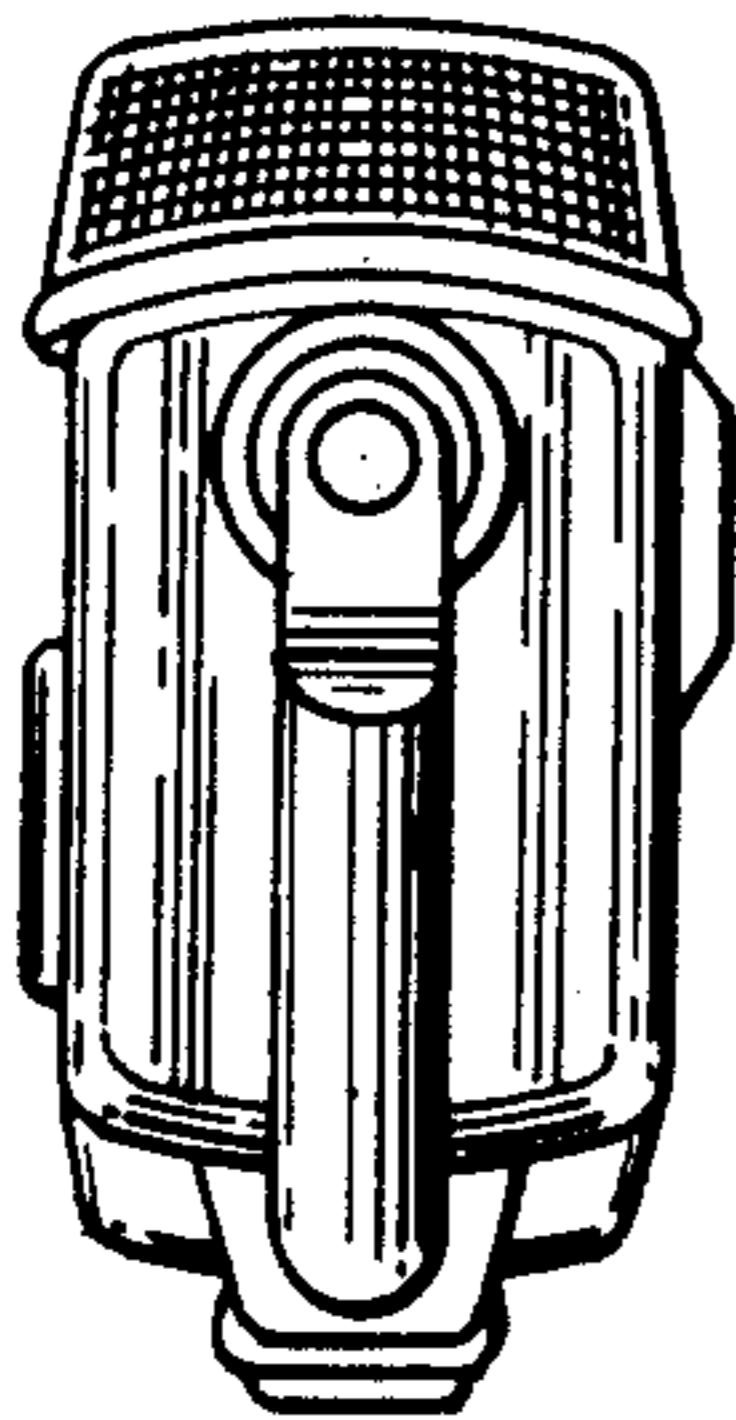


FIG. 3

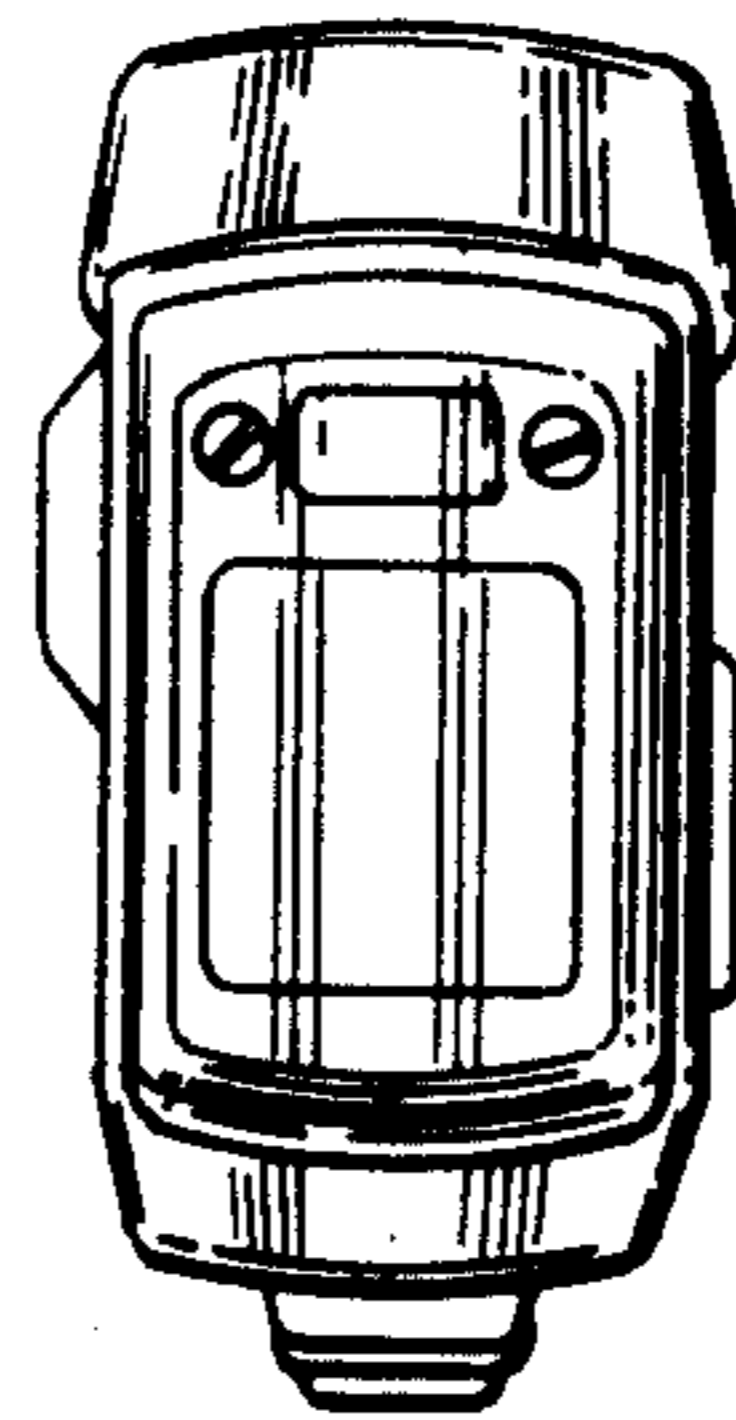


FIG. 4

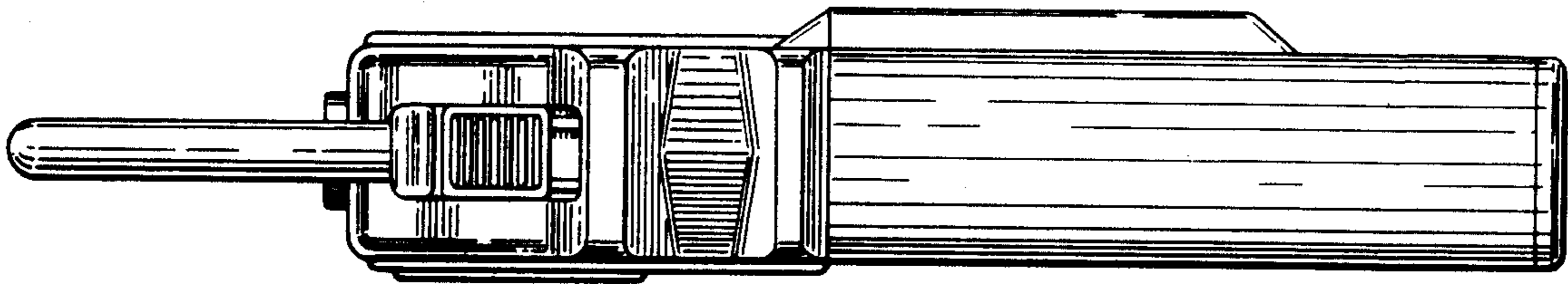


FIG. 5

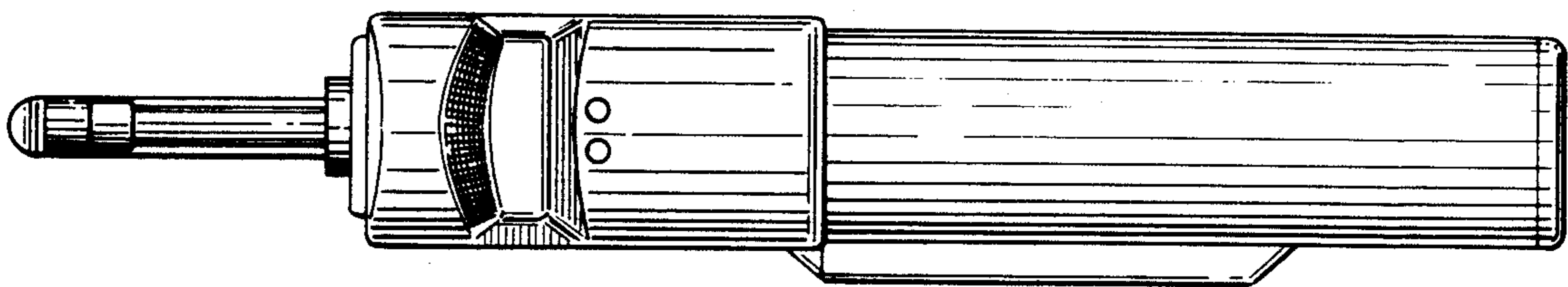


FIG. 6